

Estimation of characteristics of plasma created by electron beam generator with rare gas blown through the discharge gap

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The calculated and experimental technique of estimation of plasma characteristics has proposed. The power of electron beam and electrons mean path could be found on current-voltage characteristics and the energetic efficiency of electron beam generators. Ionization yield of gases mixture could be found in assumption about equality processes of ionization and recombination of charge particles. It has been shown that in the plasma which produced by electron beam generators in gases mixture with medium pressure key role is playing the process of dissociative recombination. Using measured current-voltage characteristics calculation of plasma characteristics in gases mixture (oxygen 20.9 %, nitrogen – 78.1 %, water vapor 1 %) at a pressure from 1 to 2,5 kPa has done.

Keywords: electron beam generators, plasma characteristics, plasma of medium-pressure gases, electron concentration.

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